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SERIAL NUMBER 10/686,768	FILING DATE 10/17/2003  RULE	CLASS 438	GROUP ART UNIT 2818	ATTORNEY DOCKET NO. SEC.1034CIP
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APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* *Yes n*

This application is a CIP of 10/457,449 06/10/2003 ABN

\*\* FOREIGN APPLICATIONS \*\*\*\*\* *Yes n*

REPUBLIC OF KOREA 2002-63567 10/17/2002

REPUBLIC OF KOREA 2003-66498 09/25/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 16	TOTAL CLAIMS 50	INDEPENDENT CLAIMS 6
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ADDRESS

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TITLE

Method of forming cobalt silicide film and method of manufacturing semiconductor device having cobalt silicide film

☐ All Fees